

Notice of References Cited	Application/Control No. 10/565,152		Applicant(s)/Patent Under Reexamination MCNIE ET AL.	
	Examiner Chad H. Smith		Art Unit 2874	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,917,596	06-1999	Jenkins et al.	356/491
*	B	US-6,934,448	08-2005	Akashi et al.	385/49
*	C	US-3,984,332	10-1976	Nelson et al.	250/368
*	D	US-6,643,309	11-2003	Gotoda, Mitsunobu	372/50.11
*	E	US-4,583,539	04-1986	Karlin et al.	606/4
*	F	US-2005/0213880	09-2005	Jones, Richard	385/030
*	G	US-5,525,190	06-1996	Wojnarowski et al.	385/133
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	R.M. Jenkins et al., A Hollow Waveguide Integrated Optic Subsystem for a 10.6 micron Range-Doppler Imaging Lidar, 2000, Proceedings of SPIE, Vol. 4034,pgs. 108 - 113.
*	V	R. Foord et al., A Hollow Waveguide Integrated Optic System with an Integrated Laser Source, 2000, Proceedings of SPIE, Vol. 4035, pgs. 346 - 353.
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.